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In re Application of RALF LERNER, et al

Application No.: 10/530,343 PCT No.: PCT/DE03/03332 Int. Filing Date: 08 October 2003 Priority Date: 08 October 2002

Attorney's Docket No.: 60291.000034

For: TRENCH INSULATION IN SUBSTRATE DISKS COMPRISING LOGIC SEMICONDUCTORS

AND POWER SEMICONDUCTORS

Dear Mr. Vivarelli,

This is in response to your letter dated 19 May 2006 requesting the status of the Form PCT/DO/EO/905 for the U.S. application identified above. The Form PCT/DO/EO/905 was mailed on 17 July 2006.

Jérentý Flending
Paralegal Specialist

Office of PCT Legal Administration

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